



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4044**  
Akihisa HONGO et al. : Attorney Docket No. 2003\_1822A  
Serial No. 10/735,771 : Group Art Unit 1763  
Filed December 16, 2003 : Examiner Sylvia Macarthur  
SUBSTRATE PROCESSING : **MAIL STOP: AMENDMENT**  
APPARATUS AND SUBSTRATE  
PROCESSING METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of November 29, 2005, kindly amend the above-referenced U.S. patent application as follows: